



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: INOUE, et al.

Serial No.: 08/921,250

Filed: August 29, 1997

For. FABRICATION METHOD OF SEMICONDUCTOR DEVICE AND ABRASIVE LIQUID USED THEREIN

Corres. and Mail

BOX AF

Group Art Unit: 1763

Examiner: GOUDREAU

#23-
9/11/02
MW

RECEIVED
SEP 09 2002
TC 1700

BOX AF

Commissioner for Patents
Washington, D.C. 20231

September 5, 2002

Sir:

In response to the Office Action dated **JUNE 5, 2002**, please amend the above-identified application as follows:

IN THE CLAIMS:

Please cancel claims 10 and 18 without prejudice or disclaimer.

L